FORM PTO-1449

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

(Use several sheets if necessary)

Docket Number (Optional)

Application Number

Sheet _ 1_ of _ 2_

637.0005USXQ

10/090,470

Applicant

Schultz et al.

Filing Date

Group Art Unit

March 4, 2002

Not Yet Assigned

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
SB	4,195,913	4/1/80	Dourte et al.	350	292	
AB	4,294,538	10/13/81	Ban /	355	51	
AB	4,389,115	6/21/83	Richter /	355	26	
db	4,651,012	3/17/87	Clark et al.	250	505.1	
AB.	4,740,276	4/26/88	Marmo et al.	204	7	
OB	5,148,442	9/15/92	O'Neil et al. 🗸	372	71	
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(YB	5,339,346	8/16/94	White /	378	34	
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SB	5,439,781	8/8/95	MacDowell et al. ,/	460	311	

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SB	NUMBER 0066295 A1	12/8/82	Europe /			Yes	
OB)	0359018 A2	3/21/90	Europe \(\)			105	No
B	0939341 A2	9/1/99	Europe /			Yes	
OB-	1026547A2	8/9/00	Europe			Yes	

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Murphy et al., "Synchrotron Radiation Sources and Condensers for Projection X-Ray Lithography", APPLIED OPTICS, Vol. 32, No. 34, pp.6920-6929 (1 December 1993)

"Handbook on Synchrotron Radiation", Ernst-Echard Koch ed., pp.140-145, 1098-1111 (1983)

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP §609; Draw line to ough

Citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

Sheet 2 of 2 7 3

FORM PTO-1449

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

Docket Number (Optional) Application Number 637.0005USXQ 10/090,470

Applicant

Schultz et al.

Filing Date

Group Art Unit

(Use several sheets if necessary) March 4, 2002

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Æ	5,440,423	8/8/95	Ogura 🗸	359	365	
AB	5,512,759	4/30/96	Sweatt /_	250	492.1	
dB	5,581,605	12/3/96	Murakami et al. 🗸	378	84	
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OB	5,755,503	5/26/98	Chen et al. 🗸	353	38	
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Ohzawa et al.

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DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Trans YES	lation NO
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5,993,010

5,995,582

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